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Filing Date		2004-02-23					
First Named Inventor	Christ	Christopher M. Look					
Art Unit		2613					
Examiner Name	Leung, Wai Lun						
Attorney Docket Number		8433P009					

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	1	5627925		1997-05-06	Alferness et al.			
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	3	5970201		1999-10-19	Anthony et al.			
	4	6332055	B1	2001-12-18	Hatayama et al. Koh et al.			
	5	6801679	B2	2004-10-05			4.3	
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_	1 20040208574 A1 2004-10-21		2004-10-21	Kinoshita et al.				
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